Substitute for form 1449APTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Complete if Known		
				Application Number	10/687.288	
				Filing Date	October 15, 2003	
				First Named Inventor	Wang Yueh	
				Art Unit	1795	
				Examiner Name	Daborah Chacko Davis	
Sheet	1	of	1	Attorney Docket Number		

NON PATENT LITERATURE DOCUMENTS						
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the stem (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, only another country where published	T <sup>2</sup>			
	"Introduction to Electron Beam Lithography," http://dot.che.gatech.edu/henderson/introduction_to_electron_beam_lithography.htm, printed from internet o					
		8/27/03, 13 pages				
			L			

Examiner	Date
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